

Message Text

CONFIDENTIAL

PAGE 01 OECD P 33410 221901Z

70

ACTION EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NRC-05 NSAE-00 TRSE-00

EUR-12 ERDA-05 ISO-00 /030 W
----- 128282

R 221848Z DEC 75

FM USMISSION OECD PARIS

TO SECSTATE WASH DC 9878

C O N F I D E N T I A L OECD PARIS 33410

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM

SUBJECT: COCOM LIST REVIEW - IL 1355, SEMICONDUCTOR
MANUFACTURING EQUIPMENT

REF: COCOM DOC. REV (74) 1355/7 (DRAFT)

1. USDEL IS IN RESERVE ON THIS DRAFT RECORD OF DISCUSSION, WHICH IS IN FRENCH. SINCE HE WAS NOT PRESENT AT DISCUSSION ON NOVEMBER 24, WHICH THE DOCUMENT RECORDS, HE IS UNABLE TO RELY ON HIS OWN NOTES AND RECOLLECTION TO CLEAR THE DRAFT. ALSO, THE INTELLIGENCE MATERIAL ON WHICH THE STATEMENT IN PARAGRAPH 4 IS BASED CANNOT BE FOUND IN OUR FILES.

2. ACTION REQUESTED: PLEASE ADVISE AS SOON AS POSSIBLE WHETHER WASHINGTON TEAM HAS CORRECTIONS OR COMMENTS TO MAKE ON THIS DRAFT, OR WHETHER US DEL CAN USE HIS DISCRETION IN CLEARING IT.
TURNER

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: AGREEMENT DRAFT, POLICIES, STRATEGIC TRADE CONTROLS, SEMICONDUCTOR DEVICES, EXCEPTIONS LIST
Control Number: n/a
Copy: SINGLE
Draft Date: 22 DEC 1975
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: GarlanWA
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1975OECDP33410
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1
Errors: N/A
Film Number: D750444-0608
From: OECD PARIS
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1975/newtext/t19751219/aaaaaqhy.tel
Line Count: 48
Locator: TEXT ON-LINE, ON MICROFILM
Office: ACTION EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Review Action: RELEASED, APPROVED
Review Authority: GarlanWA
Review Comment: n/a
Review Content Flags:
Review Date: 20 MAY 2003
Review Event:
Review Exemptions: n/a
Review History: RELEASED <20 MAY 2003 by GarlanWA>; APPROVED <30 MAY 2003 by GarlanWA>
Review Markings:

Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
06 JUL 2006

Review Media Identifier:
Review Referrals: n/a
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
Secure: OPEN
Status: NATIVE
Subject: COCOM LIST REVIEW - IL 1355, SEMICONDUCTOR MANUFACTURING EQUIPMENT
TAGS: ESTC, US, COCOM
To: STATE
Type: TE
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 06 JUL 2006